APPLICATION DATA SHEET

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Application Type:

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WAFER INCLUDING AN In-CONTAINING-COMPOUND

Title of Invention:

SEMICONDUCTOR SURFACE LAYER, AND METHOD FOR PROFILING

ITS CARRIER CONCENTRATION

Customer Number Attorney:

29453

Customer Number Correspondence Address:

29453

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Assignee (Publish): Sumitomo Electric Industries, Ltd.

5-33, Kitahama 4-chome

Chuo-ku

Osaka-shi 541-0041 Osaka JP

INVENTOR(s):

Primary Citizenship:

Japanese

Given Name:

Shigeru

Family Name:

Sawada

Residence City:

ltami-shi

Residence Country:

JΡ

Address:

c/o Itami Works of Sumitomo Electric Industries, Ltd.

1-1, Koyakita 1-chome

Itami-shi Hyogo, JP

Primary Citizenship:

Japanese

Given Name:

Takashi

Family Name:

lwasaki

Residence City:

ltami–shi

Residence Country:

JΡ

Address:

c/o Itami Works of Sumitomo Electric Industries, Ltd.

1-1, Koyakita 1-chomé

Itami-shi Hyogo, JP